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PATENT NUMBER and
ISSUE DATE

U.S. UTILITY Patent Application

APPL. NO. 10068519	FILING DATE 02/06/2002	CLASS 101	SUBCLASS -	GAU 2854	EXAMINER Funk
**APPLICANTS: Verschueren Eric; Van Damme Marc;					
**CONTINUING DATA VERIFIED: THIS APPLN CLAIMS BENEFIT OF 60/271.857 02/27/2001					
** FOREIGN APPLICATIONS VERIFIED: EUROPEAN PATENT OFFICE (EPO) 01000015.6 02/14/2001					
PG-PUB <input type="checkbox"/>		DO NOT PUBLISH <input type="checkbox"/>		RESCIND <input type="checkbox"/>	
Foreign priority claimed: <input type="checkbox"/> yes <input type="checkbox"/> no		35 USC 119 conditions met: <input type="checkbox"/> yes <input type="checkbox"/> no		ATTORNEY DOCKET NO 215293	
Verified and Acknowledged Examiners's initials TITLE : Cleaning method for recycling a printing substrate by laser ablation					

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NOTICE OF ALLOWANCE MAILED		CLAIMS ALLOWED	
		Total Claims	Print Claim for O.G.
Assistant Examiner		DRAWING	
ISSUE FEE		Sheets Drwg.	Figs. Drwg.
Amount Due	Date Paid	Print Fig.	
<input type="checkbox"/> TERMINAL DISCLAIMER		Application Examiner	
PREPARED FOR ISSUE		WARNING: The information disclosed herein may be restricted. Unauthorized disclosure may be prohibited by the United States Code Title 35, Sections 122, 181 and 368, Possession outside the U.S. Patent & Trademark Office is restricted to authorized employees and contractors only.	

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